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U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM 10083585	FILING DATE 02/27/2002	CLASS 438	SUBCLASS	GAU 2842	EXAMINER 389
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****APPLICANTS:** Iwasaki Yukiko; Shoji Tatsumi; Nishida Shoji;

****CONTINUING DATA VERIFIED:** None AKS

**** FOREIGN APPLICATIONS VERIFIED:** Yes AKS
JAPAN 076284/2001(PAT.) 03/16/2001
JAPAN 029299/2002(PAT.) 02/06/2002

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiners's initials AKS		ATTORNEY DOCKET NO 03560.002998
TITLE : Method for manufacturing a semiconductor film		

U.S. DEPT. OF COMM./PAT & TM-PTO-436L(Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner	
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